

10/510385

Docket No.: 62790 (4590-340)

PATENT
DT04 Rec'd PCT/PTO 06 OCT 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Confirmation No.
Pierre-Olivier LEFORT et al. :
U.S. Patent Application No.: *pending* : Group Art Unit:
Filed: *herewith* :
:

For: METHOD FOR THE PRODUCTION OF A MICROSTRUCTURE COMPRISING A
VACUUM CAVITY AND A MICROSTRUCTURE

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to examination of the above-referenced application, please amend the application as follows: